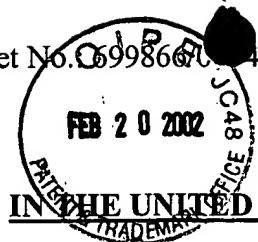


Atty. Docket No. 0699867004  
LR:DMF



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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: Hisashi Ohtsuka et al.

Serial No.: 09/552,540

Art Unit: 2881

Filed: April 19, 2000

Examiner: C. Harmon

For: SOLID-STATE LASER APPARATUS EXCITED BY LASER  
LIGHT FROM SEMICONDUCTOR

February 4, 2002

**PETITION FOR EXTENSION OF TIME**  
**PURSUANT TO 37 C.F.R. §1.136(a) AND FEE AUTHORIZATION**

Commissioner for Patents  
Washington, D.C. 20231

Sir:

Applicants respectfully petition the Commissioner for a one-month extension of time to file a response to an Office Action dated October 3, 2001 (the "Office Action"). Applicants also authorize the Commissioner to charge Deposit Account No. 19-4709 in an amount of \$110.00 for this Petition. This Petition and the response to the Office Action are being filed within three months of the shortened statutory period.

02/27/2002 RHARIS1 00000156 194709 09552540

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**Certificate of Mailing (37 C.F.R. 1.8)**

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: *Assistant Commissioner for Patents, Washington, D.C. 20231*, on (Date) February 4, 2002.  
Typed or printed name of person signing this certificate:

Helen Giglio

Signature: Helen Giglio

February 4, 2002

Kindly charge any additional fees or charges required at this time and in connection with  
the present application to Deposit Account No. 19-4709.

Respectfully submitted,

*for:* David S. Rosenthal Reg. No. 42,518  
Lawrence Rosenthal  
Registration No. 24,377  
Attorney for Applicant  
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